## ACTIVE MATERIALS>>-3-

## XY200M: A new design of XY piezo stage for nanopositioning applications !

Thomas Maillard, Ronan Le Letty - CEDRAT TECHNOLOGIES.

he XY200M is an XY piezo stage coming from CEDRAT TECHNOLOGIES lab and which was newly designed according to space needs defined with CNES (the French space agency). This XY stage benefits from the heritage of a former XY stage developed for ESA (European Space Agency) in the frame of Rosetta / Midas space mission which will launch in the beginning of 2003. It is based on two pairs of APA200M, Amplified Piezo Actuators displaying 200 µm of stroke each, arranged in cross configuration around a central ring (see figures 1 & 2). The mechanism allows a displacement of +/- 100 µm along the two orthogonal X and Y axis with very low parasitic motions (out of plane displacements and rotations around the Z direction, see figure 4 - data sheet). In order to achieve the two

X and Y displacements, each pair of APA200M is electrically driven in push pull configuration, so the device only requires two output channels from the standard driving electronics LA75A-2 of CEDRAT TECHNOLOGIES. In the context of this R&T CNES project, the aim was to space evaluated this concept of self thermo-mechanically centred stage. For instance this device passed the launch vibrations test with a payload mass of 0.1 kg without neither clamping or latching mechanism. The central ring motion can be precisely controlled using either strain gages (SG option, figure 2) or capacitive sensors

(CS option, figure 1). Taking benefit of the **innovations** brought in this **space version**, **CEDRAT TECHNOLOGIES** decided to **upgrade** its **industrial standard version** of the **XY200M** (see figure 4, technical data sheet of the standard derived from the space version) in order to offer the **state of the art** to its **customers**. Applications targeted are **nanopositioning** of **lenses**, **mirrors** and **CCD** or **LCD sensors**, **2D scanning**...

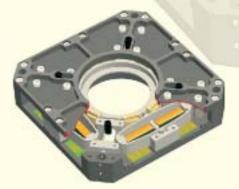


Figure 3: XY200M-SG space version stage with Strain Gages option - Side view.



Figure 1: 3D view (I-DEAS) of the XY200M space version stage with Capacitive Sensor option.



Figure 2: XY200M-SG space version stage with Strain Gages option -Opened top view.

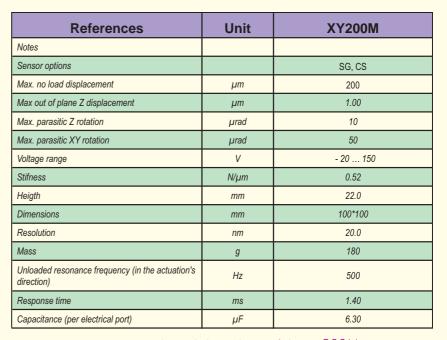


Figure 4: Technical data sheet of the XY200M



株式会社キーストンインターナショナル TEL: 04-7175-8810 mail: key@keystone-intl.co.jp N° 40 - September 2002 - CEDRAT - CEDRAT TECHNOLOGIES - MAGSOFT Corp.